

<b>Notice of References Cited</b>	Application/Control No. 10/602,529	Applicant(s)/Patent Under Reexamination STEINMETZ ET AL.	
	Examiner Kim Huynh	Art Unit 2182	Page 1 of 1

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	C	US-5,941,972	08-1999	Hoese et al.	710/315
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	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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